

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	180	(703/9).CCLS.	USPAT; USOCR	OR	OFF	2006/05/19 10:03
S2	9	S1 and plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:22
S3	4	plasma near2 character\$6 same plurality adj3 section\$2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:24
S4	48	(plasma near2 character\$6) and (plurality adj3 section\$2)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:25
S5	4	(plasma near2 character\$6) and (plurality adj3 section\$2) and chamber and magnets	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/21 09:25
S6	2	((("60009255") or ("5590051") or ("5421934"))).PN.	USPAT; USOCR	OR	OFF	2006/05/19 10:03
S7	3	((("6009255") or ("5590051") or ("5421934"))).PN.	USPAT; USOCR	OR	OFF	2006/05/19 11:24
S8	3	((("6014943") or ("5801971") or ("6199029"))).PN.	USPAT; USOCR	OR	OFF	2006/05/19 12:59
S9	58	plasma and character\$5 and (plurality near cross\$section\$2)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 13:01
S10	0	plasma near character\$5 and (plurality near cross\$section\$2)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 13:01
S11	1	plasma and character\$5 and (plurality near cross\$section\$2) and species and monte	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 13:01
S12	9039	plasma and (two\$dimension\$3) and (cross\$section\$3 or etch\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:37

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S13	648	plasma same (two\$dimension\$3) and (cross\$section\$3 or etch\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:37
S14	177	plasma same (two\$dimension\$3) same (cross\$section\$3 or etch\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:37
S15	2	plasma same (two\$dimension\$3) same (cross\$section\$3 or etch\$3) and poisson	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:38
S16	379	plasma same (cross\$section\$3 or etch\$3) and poisson	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:38
S17	9	plasma same (cross\$section\$3 or etch\$3) same poisson	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 15:38
S18	564	((216/71) or (216/72) or (216/68)).CCLS.	USPAT; USOCR	OR	OFF	2006/05/19 18:31
S19	20	S18 and plasma near2 character\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/05/19 18:31
S20	1	("6678876").PN.	USPAT; USOCR	OR	OFF	2006/09/10 12:50
S21	20	("4500963" "4642890" "5245550" "5636129" "5657242" "5717600" "6256769" "6385758" "6490713").PN. OR ("6678876").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/09/10 12:53

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